

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Fumihito OKA et al.

Application S/N: 09/925,626

Filed: August 10, 2001

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: Group Art Unit: 2811
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: Examiner: S. Hu
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For: CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE,
CRYSTALLINE SILICON THIN FILM PHOTOVOLTAIC DEVICE, AND PROCESS FOR
PRODUCING CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE

NOTIFICATION OF ATTORNEY'S CHANGE OF ADDRESS

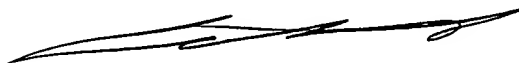
Honorable Assistant Commissioner
for Patents
Washington, DC 20231

Sir:

Counsel for Applicants is located at the address given below and, effective immediately, requests that all Patent Office documents, notices, correspondence, etc. be mailed directly to such address:

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